

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Takashi KAITO et al. :
Appln. No. 10/759,354 : Group Art Unit - 1763
Filed: January 16, 2004 : Examiner- Rodney Glenn
McDonald
For: METHOD AND SYSTEM FOR :
SURFACE OR CROSS-SECTIONAL:
PROCESSING AND OBSERVATION: Docket No. S005-5191

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COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL
UNDER RULE 116**

S I R:

In response to the Office Action dated October 31,
2006, applicants amend their application as follows:

ADDITIONAL FEE:

No additional fee is believed required in connection
with this response. However, should it be determined that a
fee is due, authorization is hereby given to charge any such
fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 19

